



INTERNATIONAL
GEMOLOGICAL
INSTITUTE

ELECTRONIC COPY

LABORATORY GROWN DIAMOND REPORT

September 16, 2026

IGI Report Number

Description

Shape and Cutting Style

Measurements

LG836674458

LABORATORY GROWN DIAMOND

MODIFIED OVAL STEP CUT

10.41 X 7.72 X 4.75 MM

GRADING RESULTS

Carat Weight

Color Grade

Clarity Grade

3.01 CARATS

D

VS 1

ADDITIONAL GRADING INFORMATION

Polish

Symmetry

Fluorescence

EXCELLENT

EXCELLENT

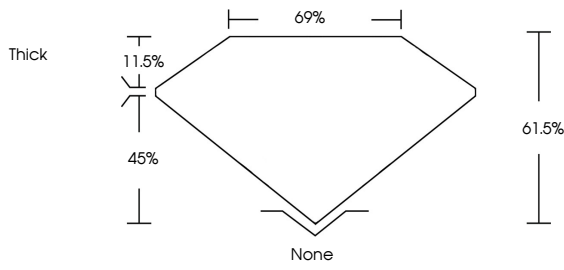
NONE

Inscription(s)

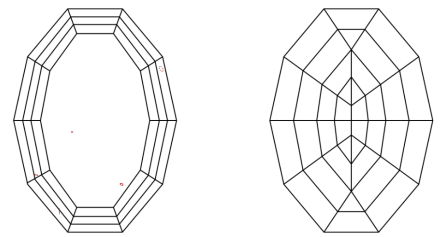
Comments: This Laboratory Grown Diamond was created by Chemical Vapor Deposition (CVD) growth process. Type IIa



PROPORTIONS



CLARITY CHARACTERISTICS



KEY TO SYMBOLS

Red symbols indicate internal characteristics.

Green symbols indicate external characteristics.

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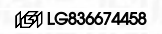
EXCELLENT

EXCELLENT

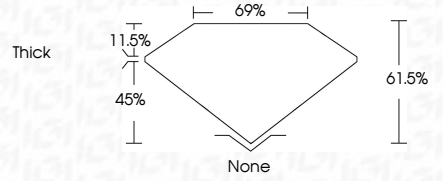
NONE

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PROPORTIONS



COLOR

D E F G H I J Faint Very Light Light

CLARITY

FL IF VVS 1-2 VS 1-2 SI 1-2 I 1-3

Flawless Internally Flawless Very Very Slightly Included Very Slightly Included Slightly Included Included



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September 16, 2026

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MODIFIED OVAL STEP CUT

3.01 CARATS

D

VS 1

D

61.5%

69%

Thick

None

EXCELLENT

EXCELLENT

NONE

IGI LG836674458

Carat Weight

Color Grade

Clarity Grade

Depth

Table

Girdle

Culet

Polish

Symmetry

Fluorescence

Inscription(s)

10.41 X 7.72 X 4.75 MM

3.01 CARATS

D

VS 1

D

61.5%

69%

Thick

None

EXCELLENT

EXCELLENT

NONE

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